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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Trung T. Doan

Serial No.: 09/652,969

Filed: August 31, 2000

For: CHEMICAL DISPENSING SYSTEM FOR  
SEMICONDUCTOR WAFER PROCESSING

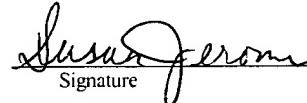
§ Group Art Unit: 1763 **RECEIVED**  
§ Examiner: Sylvia MacArthur **NOV 03 2003**  
§ Atty. Docket: 93-04201 **OFFICE OF PETITIONS**  
§  
§  
§

Mail Stop 313(c)  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop 313(c), Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

Date 10/30/03

  
Signature

October 30, 2003

PETITION TO WITHDRAW FROM ISSUE

Dear Sir:

Applicant seeks to withdraw the above captioned application under 37 CFR section 1.313(c)(2) – for consideration of a Request for Continued Examination. Applicants paid the issue fee on October 13, 2003, but have not yet received Notice of Issuance. The Commissioner is authorized to charge the fee of \$130 required under 37 CFR section 1.17(h), as well as any additional fees which may be required, to Micron Technology, Inc., Deposit Account No. 13-3092, Order No. 93-0421.05.

Accordingly, a Request for Continued Examination is being concurrently submitted.

Please address further correspondence with this application to: Charles B. Brantley, II,  
Micron Technology, Inc., Mail Stop 1-525, 8000 S. Federal Way, Boise, ID 83716-9632,  
telephone number (208) 368-4557.

MICRON TECHNOLOGY, INC.

Date 10/29/13

Charles Brantley  
Charles B. Brantley II, Reg. No. 38,086